

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : M.A. Northrup and R.M. White Art Unit: 1634
Serial No.: 08/482,933 Examiner: Marschel, A.
Filed : June 6, 1995
Title : MICROFABRICATED REACTOR

Assistant Commissioner for Patents
Washington, DC 20231

AMENDMENT UNDER 37 CFR § 1.111 AND REQUEST
FOR INTERFERENCE UNDER 37 CFR § 1.607

In response to the Office Action of March 31, 1998,
kindly amend the above identified application as follows:

IN THE RELATED APPLICATIONS PARAGRAPH

Page 1, line 2: After "is", insert --a continuation of
our application No. 07/938,106 filed on August 31, 1992, now U.S.
Patent No. 5,639,423. This application is also--.

IN THE CLAIMS

83. (Amended) The process of claim 81 a process for
manufacturing on a wafer an instrument for controlling a chemical
reaction, comprising the steps of etching said wafer to form a
reaction chamber, further comprising the step of and depositing a

Date of Deposit
I hereby certify under 37 CFR 1.8(a) that this correspondence is
being deposited with the United States Postal Service as first class
mail with sufficient postage on the date indicated above and is
addressed to the Assistant Commissioner for Patents, Washington,
D.C. 20231.